

PHASE-LOCKED LOOP WITH CONDITIONED CHARGE PUMP OUTPUT

Cross-Reference to Related Applications

This application claims the benefit under 35 U.S.C. § 119(e) of U.S. provisional
5 patent application Serial No. 60/408,702, filed September 6, 2002, which is hereby
incorporated by reference in its entirety for all purposes. This application is also a
continuation-in-part of U.S. Patent Application Serial No. 10/059,945, filed January 28,
2002, which is hereby incorporated by reference in its entirety for all purposes.

Technical Field

10 The present description relates to phase-locked loop systems, and more
particularly to phase-locked loop systems where charge pump output is conditioned in the
proportional control path of the loop to improve jitter performance, and/or where the
charge pump currents are scaled to vary performance of the phase-locked loop.

Background of the Invention

15 Phase-locked loop (PLL) systems are used extensively in analog and digital
circuits. These systems typically include a phase frequency detector (PFD), charge pump
and voltage controlled oscillator (VCO) connected in a feedback configuration. The
VCO produces the output signal of the PLL, and the various components of the PLL
cooperate to cause the output signal to tend toward and eventually lock on to a desired
20 output frequency, which is based on a reference signal applied as an input to the PFD.
For example, many PLL systems are configured to produce an output signal having the

same frequency as the input signal, or having an output frequency which is a factor x/y of the input frequency.

The output signal tracks the desired output frequency through operation of a feedback mechanism, in which the output of the VCO is fed back to the PFD as a
5 feedback signal via a feedback path. The phase frequency detector receives the reference signal and the feedback signal, and produces an error signal based on discrepancies between the actual phase and frequency of the output signal and the desired phase and frequency. The error signals from the PFD are applied to the charge pump, which in turn produces signals that control the oscillation frequency of the VCO.

10 Minimizing or reducing uncontrolled jitter in the output signal is an important design issue in PLL systems. Jitter is variation in the phase and/or frequency of the output signal when the system is aligned or very nearly aligned. Most PLL systems exhibit some amount of jitter in the output signal. Indeed, many PLL systems have what is known as a “dead band,” or a range of output alignments through which the system
15 exerts little or no control over the output signal. This problem is addressed in some designs through phase frequency detectors configured to generate simultaneous canceling error signals when the system is in lock. Despite this solution, many of these systems still exhibit an unacceptably high level of jitter, particularly where the systems are used to multiply the frequency of the reference signal. Also, even where jitter is reduced to an
20 acceptable level, many such systems exhibit an undesirable amount of static phase offset in the output signal, that is, an average phase discrepancy between the output signal and the desired phase.

In addition to the above problems, many existing PLL systems have other shortcomings which can have undesirable affects on the PLL output signal. For example, some systems suffer from undesired signal coupling between the various PLL components, which can lead to noise or jitter in the output signal. In other designs, the VCO and other PLL components are susceptible to voltage variations or noise coupled into the system from the voltage supply or other sources.

In addition, conventional phase-locked loops typically include components designed to operate under fixed or relatively fixed conditions. This can reduce the flexibility of the design, and constrain its use to a limited range of applications. For example, many PLL systems are designed for frequency multiplication by a predetermined scale factor, or are designed with predetermined dynamic characteristics (e.g., damping and bandwidth response) that are fixed at design time.

Summary of the Invention

The present description provides a phase-locked loop system configured to cause an output signal to tend toward a desired output frequency. The phase-locked loop system includes a charge pump system configured to produce a charge pump output based on differences detected between the output signal and the desired output frequency. The phase-locked loop further includes an oscillator operatively coupled with the charge pump system and configured to produce the output signal based on the charge pump output. The charge pump system is configured to selectively effect proportional control over the output signal by producing a correcting pulse having a duration and applying the correcting pulse to a proportional control path of the phase-locked loop system. The

charge pump system also includes a correcting circuit configured to store a correcting charge corresponding to the correcting pulse, and then output the correcting charge over a period of time that is greater than the duration of the correcting pulse.

According to another aspect of the invention, a method is provided for reducing jitter in a phase-locked loop system. The method includes receiving a correcting pulse, storing a charge based on the correcting pulse, and outputting the stored charge over a period of time that is greater than the duration of the correcting pulse.

According to further aspects of the invention, phase-locked loops are provided that employ programmable current mirrors, and other structures and methods, to reduce charge pump current within the phase-locked loop.

Brief Description of the Drawings

Fig. 1 is a block diagram of a phase-locked loop system according to the invention.

Fig. 2 depicts a charge pump that may be implemented with the system of Fig. 1.

Fig. 3 depicts a charge pump and bias generator that may be implemented with the system of Fig. 1.

Fig. 4 depicts a multistage voltage controlled oscillator that may be implemented with the system of Fig. 1.

Fig. 5 depicts a circuit that may be implemented to isolate biasing signals within the charge pumps of the present description.

Fig. 6 depicts a current mirror system that may be employed within a proportional control path between the charge pumps and bias generators of the present description.

Fig. 7 depicts exemplary waveforms of a reference signal, output signal and correction signal occurring in a frequency-multiplying phase-locked loop.

Fig. 8 depicts a circuit according to the present description that is configured to receive a correcting pulse and output a plurality of smaller correcting pulses within the proportional control path of the system shown in Fig. 1.

Fig. 9 depicts a correction system according to the present description that is configured to receive a correcting pulse and output a corresponding charge-equivalent current into the proportional control path of the system shown in Fig. 1.

Fig. 10 is a circuit-level representation of the correction system shown in Fig. 9.

Fig. 11 depicts a method of reducing output jitter in a PLL system according to the present description.

Fig. 12 depicts another embodiment of a proportional control correcting circuit according to the present description.

Figs. 12A – 12D depict further embodiments of a correcting circuit according to the present description.

Fig. 13 depicts exemplary sampling waveforms occurring in the correcting circuit shown in Fig. 12.

Fig. 14 depicts a charge pump system according to the present description that is configured to effect proportional and integral control over a PLL output signal via operation of a sampling/switching network provided in the integrating and control paths of the system shown in Fig. 1.

Fig. 15 depicts use of a single charge pump to effect proportional and integral control over a PLL output signal via operation of a sampling/switching network provided in the integrating and control paths of the system shown in Fig. 1.

5 Figs. 16 – 19 depict current mirror configurations according to the present description that may be used to scale charge pump currents occurring in the system shown in Fig. 1.

Fig. 20 depicts a gating mechanism according to the present description for reducing charge pump currents occurring in the system shown in Fig. 1.

Detailed Description of the Invention

10 A phase-locked loop (PLL) system is depicted generally at 10 in Fig. 1. PLL system 10 is configured to produce an output signal 12 (F_o) in response to application of a reference signal 14 (F_r), such that the output signal tends toward a desired output frequency which is based on reference signal 14. For example, the output signal may have the same frequency as the input reference signal, or the output frequency may be a
15 rational factor x/y of the reference frequency.

As indicated, PLL system 10 operates via a feedback arrangement, where output signal 12 is fed back and applied as a feedback input F to an error detector. The present description will be described primarily in the context of phase-locked loops which implement the error detector as a phase frequency detector (PFD) 16. It will be
20 appreciated, however, that the present description is applicable to a wide variety of settings where error detection and feedback mechanisms are employed to cause an output signal to have a desired characteristic. For example, other types of error detectors with

which the present description may be used include XOR devices, mixers, edge-triggered latches and sampling flip-flops.

Still referring to Fig. 1, PFD 16 also receives reference signal 14 as a reference input R. PFD 16 detects phase/frequency differences between the signals applied to the reference and feedback inputs, and produces one or more outputs based on the detected differences. Typically, as indicated, the PFD output will take the form of a “U” signal 18, a “D” signal 20, or a combination of those signals. PFD 16 produces the U signal where the actual, or instantaneous, output frequency is lower than the desired output frequency, and/or where the output signal lags the desired output in phase. The D signal is produced where the actual output frequency is higher than the desired output frequency, and/or where the output signal leads the desired output in phase.

PLL system 10 typically also includes a charge pump system 22, bias generator 24 and one or more filters such as low pass filter 26. These components respond to the U and D signals to produce a control signal 28 (V_{bn}) that is applied to control a voltage controlled oscillator (VCO) 30. V_{bn} may also be referred to as a biasing signal, because it typically is used to control various current sources and other components in the phase-locked loops of the present description. For example, as depicted, V_{bn} may be fed back to charge pump system 22 to dynamically bias operation of the charge pump, as will be explained in more detail. Based on application of biasing signal V_{bn} , VCO 30 produces output signal 12, either directly or with subsequent processing by signal converter 32 or other components.

For example, in an implementation where output signal 12 (F_o) is to track reference signal 14 (F_r) without frequency multiplication or division, assume at a given instant that output signal 12 has a lower frequency than the applied reference signal 14. PFD 16 detects this difference and responds by producing one or more U pulses 18. The U pulses then cause a change in biasing signal 28 (resulting, for example, in an increase in current supplied to VCO 30) that produces an increase in the phase and/or frequency of the VCO output signal F_o . The charge pump continues to output U pulses until the output frequency equals the reference frequency.

As indicated, output signal 12 may undergo various processing within feedback path 34 before being applied as the feedback input to PFD 16. For example, in PLL applications where the reference frequency is multiplied by a factor to produce the output frequency, the feedback path typically will include a divider 36 and/or other components. Co-pending U.S. Patent Application No. 10/059,913, filed on January 28, 2002, provides additional examples of feedback processing and other components and features that may be implemented with the present description. Co-pending U.S. Patent Application No. 10/059,503, filed on January 28, 2002, provides additional examples of PLL systems and components that may be implemented with the present description. The disclosures of those patent applications are incorporated herein by this reference, in their entirety and for all purposes.

Figs. 2, 3 and 4 respectively depict in further detail charge pump system 22, bias generator 24 and VCO 30 according to the present description. Charge pump system 22 typically includes an integrating charge pump 40 configured to provide output to the V_{ctrl}

node of bias generator 24 in response to error signals received from PFD 16 (i.e., U and/or D pulses). The level of V_{cntl} is maintained at the input of bias generator 24 via capacitor 42. Charge pump 40 causes the V_{cntl} level to increase, decrease or remain constant based on the U and D signals applied from PFD 16. Based on V_{cntl} , bias generator 24 produces biasing signal V_{bn} , which is applied to the current sources that drive charge pump 40 and VCO 30. At charge pump 40, biasing signal V_{bn} essentially controls the sensitivity of the charge pump to the U and D signals. In other words, the biasing signal controls the extent to which application of these signals causes the V_{cntl} output to vary. At VCO 30, biasing signal V_{bn} acts as the primary input to the oscillator, and controls its output frequency.

As seen in Figs. 1 and 2, PFD 16 typically includes separate output lines for the U and D signals. Accordingly, charge pump 40 may include a U portion and a D portion configured to receive the corresponding error signals from the PFD. Each portion contains one or more current paths which are controlled by biasing signal V_{bn} and through application of the error signals received from PFD 16. The currents flowing through the paths create various node voltages which ultimately determine the behavior of the control signal V_{cntl} .

Referring particularly to Fig. 2, transistors 50 and 52 act as current sources. These transistors are biased by V_{bn}' , a mirrored copy of biasing signal V_{bn} , as will be explained below. Transistors 54 and 56 steer current into one of two diode-connected transistors 58 and 60, and transistors 62 and 64 steer a matched current into the depicted V_{cntl} terminal, or into diode-connected transistor 66. The current mirror formed by transistors 60 and 68

sources as much charge into V_{cntl} as is drained through transistor 60, subject to certain limitations discussed below. Because transistors 54, 56, 62 and 64 control activation of the various current paths within the charge pump in response to the U and D error signals, those transistors may be collectively referred to as a switching device.

5 From the above, it should be understood that application of the U signal from PFD 16 causes V_{cntl} to fall, while application of the D signal causes V_{cntl} to rise. As will be explained in more detail, decreases in V_{cntl} produce an increase in biasing signal V_{bn} and an increased bias current I_b within bias generator 24 (Fig. 3). The increase in biasing signal V_{bn} causes the current supplied to VCO 30 to rise. This increased VCO current
10 produces positive phase and/or frequency adjustments to output signal 12. Conversely, when V_{cntl} increases (e.g. from pulsing of the D signal), the bias current I_b and biasing signal V_{bn} drop. This decreases the current supplied to VCO 30, which in turn produces negative adjustment to the phase and/or frequency of output signal 12.

 In typical implementations of the present description, the error signals output by
15 PFD 16 tend to have a stabilizing effect upon the output signal when the system is in lock. Conversely, in the absence of either a U or a D signal (as might occur if little or no discrepancy were detected between the two signals applied to the inputs of PFD 16), output signal 12 tends to drift about the desired output frequency instead of achieving a stable lock. The range of alignments in which this drift effect occurs is known as a “dead
20 band.” The dead band results partly from the narrowing of the U and D pulses as the system approaches lock. Narrower pulses are often filtered out by various components in the system, such that the system is unable to correct discrepancies between the output

signal and the desired output frequency until those discrepancies exceed some threshold magnitude. The resulting output jitter is often undesirable.

To eliminate or reduce this undesired jitter in the output signal, PFD 16 may be configured to emit both U and D pulses when the PFD inputs are aligned or nearly aligned. When only one of the signals is applied, charge pump system 22 pumps a net charge to bias generator 24, in order to produce variation in the phase and/or frequency of the output signal. By contrast, where both the U and D signals are applied together (simultaneously) to charge pump 40, the charge pump should pump no net charge.

Typically, when U and D are pulsed simultaneously to avoid a dead band, the respective effects of those error signals are at least partially canceled via operation of the current mirror defined by transistors 60 and 68 (Fig. 2). Theoretically, the current mirror ensures that the current through transistors 60 and 68 will be equal, leaving no net output charge from charge pump 40, and ensuring no variation of the V_{cntl} level on capacitor 42. If a net charge were pumped in such a situation, the variation in V_{cntl} would introduce an undesired variation in output signal 12. Specifically, such charge leakage can produce undesired static phase offset in output signal 12.

The current through transistors 60 and 68 would be equal if charge pump 40 contained an ideal current mirror and two ideal switchable current sources with infinite output impedance. However, these devices typically are not ideal in practice, and the phase-locked loops described herein normally include some mechanism to force the voltage V_{cntl} to equal the V_{int} gate voltage on transistor 60. This causes the charge pump

output current to be zero when U and D are asserted, leaving no net effect upon the V_{cntl} voltage stored on capacitor 42.

Bias generator 24 dynamically varies its output biasing signal V_{bn} in order to balance the charge pump output when U and D signals are simultaneously applied to charge pump 40. As the current being steered through transistor 60 grows larger, the voltage on V_{int} grows smaller. Bias generator 24 is configured to find and supply a V_{bn} level for which the voltage V_{int} will equal the voltage V_{cntl} . Bias generator 24 contains an amplifier 80 and a replica of the current path through the D side of charge pump 40 when the D signal is pulsed. The replica current path includes transistors 82, 84 and 86. The negative feedback through the amplifier causes V_{replica} to be equal to V_{cntl} by appropriately adjusting the biasing current I_b set by V_{bn} .

With both U and D high, the activated current path on the left side of the charge pump will look identical to the replica current path within bias generator 24, so that V_{int} will equal V_{replica} , which the bias generator forces to equal V_{cntl} . The right side of charge pump 24 is similar, but the gate of transistor 68 is not connected to its drain. However, like transistor 60, both the gate and drain voltages will be V_{cntl} . Thus, the right side of the charge pump should behave identically to the left side so that the current sourced by transistor 68 will exactly match the current sunk by transistor 62 leaving no net output current.

With no output current from the charge pump when both U and D are high, there should be no net charge output when U and D are pulsed identically, as would occur in a

locked condition with zero static phase offset. Phase-locked loops with this arrangement may thus be considered self-biased phase-locked loops.

As should be appreciated from the above discussion, biasing signal V_{bn} is dynamically generated free of any external bias levels. In addition to balancing operation of charge pump system 22, the biasing signal dynamically controls other current sources within phase-locked loop 10. Also, the dynamic operation of bias generator 24 causes the bias generator to maintain a regulated bias generator voltage that is independent of fluctuations in the V_{dd} and V_{ss} supplies. The regulated bias generator voltage is matched to a regulated voltage in VCO 30, which improves supply and substrate noise rejection of the PLL system.

As indicated, bias generator 24 is also configured to produce a secondary biasing signal V_{bp} , which may be used to facilitate biasing of the voltage controlled oscillator, as described in detail in above-referenced co-pending U.S. Patent Application No. 10/059,503, filed on January 28, 2002.

As indicated above, charge pump system 22 typically includes an integrating charge pump 40 to provide integrating control over output signal 12. In many cases, it will also be desirable to employ proportional control to achieve stable feedback. Accordingly, as seen in Fig. 3, charge pump system 22 may also include a proportional charge pump 90.

Typically, integrating charge pump 40 and proportional charge pump 90 are similar, if not identical, in construction and internal operation. Both pumps respond to the U and D error signals by pumping charge for application to bias generator 24, in order

to produce adjustments to output signal 12. Also, both pumps are biased via feedback coupling of biasing signal V_{bn} (or mirrored copy V_{bn}') from bias generator 24.

The two charge pumps are distinguished by the signal path to bias generator 24, and by the way pumped charge is applied to the bias generator. Integrating charge pump 40 pumps its output charge along an integrating control path defined between V_{cntl} node of charge pump 40 and the V_{cntl} input terminal of bias generator 24. The pumped charge is integrated by and stored at capacitor 42. The voltage on this capacitor represents the net accumulated charge resulting from all of the previously applied U and D signals to integrating charge pump 40.

By contrast, proportional charge pump 90 pumps its output charge via a proportional control path to the $V_{replica}$ node of bias generator 24. The output charge typically is in the form of a current pulse I_{bp} which is added to or subtracted from the I_b bias current flowing within the replica current path in bias generator 24. In some cases, there may be various capacitances introduced into the proportional control path, though these capacitances typically are much smaller than capacitor 42. Accordingly, the proportional control provided by charge pump 90 normally involves small phase adjustments to output signal 12, where the integrating control provided by integrating charge pump 40 typically involves more gradual adjustments to the frequency of the output signal, due to the accumulated charge on capacitor 42 and the filtering effects produced by the relatively large capacitance.

As indicated above, when phase-locked loop 10 is in lock, PFD 16 emits small, equal-sized U and D pulses to charge pump system 22. These pulses can capacitively

couple into biasing signal V_{bn} through transistors 54, 56, 62, 64, 50 and 52 of integrating charge pump 40. Similar signal coupling can occur in proportional charge pump 90. The resulting periodic noise on biasing signal V_{bn} may cause some cycle-to-cycle jitter, since the biasing signal is also used to drive VCO 30. As seen in Fig. 5, the charge pump system may include an isolated bias input path 100 to isolate biasing signal V_{bn} and avoid the jitter described above.

As indicated in Fig. 5, isolated bias path 100 typically includes a number of transistors (e.g., transistors 102, 104, 106, 108, 110 and 112) which define a current mirror system. The current mirror produces a mirrored copy V_{bn}' of the V_{bn} biasing signal generated by bias generator 24. The mirrored biasing signal V_{bn}' is then used in the charge pumps, so that noise coupled onto it does not affect VCO 30. The left transistor stack essentially creates a local copy of the secondary biasing signal V_{bp} generated by bias generator 24. In some settings, it may be desirable to directly use the secondary biasing signal in the right transistor stack, instead of generating a local copy.

U.S. Patent No. 6,462,527, issued October 8, 2002, provides additional examples of current mirroring devices that may be employed with the present description. The disclosure of that application is incorporated herein by this reference, in its entirety and for all purposes.

As discussed above, bias generator 24 includes a feedback loop that actively tracks V_{cntl} to generate a dynamic biasing signal which controls both the charge pump system 22 and VCO 30. For reasons explained below, it typically is important that this feedback

loop exhibit a bandwidth response that is much faster than the overall bandwidth of the PLL system.

However, in some cases it will be desirable to couple components within the proportional control path (e.g., between proportional charge pump 90 and the V_{replica} node of bias generator 24) that may affect the dynamic response of the bias generator feedback loop. Where these components are used, and in other cases, coupling proportional charge pump 90 and these components directly to bias generator 24 can increase the capacitance on V_{replica} . Large increases in this capacitance can destabilize the feedback loop within the bias generator. This can be countered with an increase in the capacitance on biasing signal V_{bn} , though such an increase would reduce the bandwidth of the bias generator, which in turn can reduce the supply and substrate noise rejection of the VCO, as will be explained below.

These issues may be addressed by providing proportional charge pump 90 with an isolated output 120 within the proportional control path, as seen in Fig. 6. Isolated output 120 includes a number of transistors which define a current mirror system. The current mirror system is pre-biased by biasing signal V_{bn} from bias generator 24, and replicates initial output I_{bp} (but with opposite sign), so that output I_{bp} is applied to the V_{replica} node of the bias generator, as discussed above with reference to Fig. 3. The U and D inputs may be reversed on the proportional charge pump to compensate for the change in sign. The depicted current mirror system isolates proportional charge pump 90 from bias generator 24. This allows use of an arbitrary capacitance 122, or other components in the proportional control path, without affecting damping, bandwidth or other dynamic

characteristics of the feedback loop contained within bias generator 24. Further filtering and signal isolation may be provided by cascading additional stages to the depicted isolation circuit.

As discussed above, the output from charge pump system 22 controls the oscillatory response of voltage controlled oscillator 30, and has various effects upon the overall performance of PLL system 10. For example, the magnitude of the charge pump output currents affects the bandwidth response of the PLL system. In addition, where the charge pump output includes pulsed components (e.g., current pulses), the frequency at which those components are provided to bias generator 24 affects the frequency at which adjustments are made to the PLL output signal (i.e., output signal 12). Accordingly, it will often be desirable to employ additional components to condition the charge pump output and thereby vary its effects upon the performance of the PLL system.

Conditioning certain components of the charge pump output may be desirable in applications where the PLL system is configured to multiply the reference frequency. Fig. 7 depicts various exemplary waveforms that may occur in a PLL system configured to multiply the reference frequency by an integer value N . Specifically, Fig. 7 depicts several cycles of reference signal 14, and several cycles of VCO output signal 12, where the reference frequency is multiplied by a factor of $N = 3$. As indicated, the phase frequency detector applies a correction signal 200 to the loop once per reference cycle. In typical configurations, this correction signal is a current pulse.

The current I_{bp} generated by proportional charge pump 90 (Fig. 3) and added to the V_{replica} node of bias generator 24 is an example of such a pulsed correction signal.

Because proportional charge pump 90 adds the I_{bp} current directly to bias generator 24, only one of every N VCO output cycles is adjusted (e.g., lengthened or shortened) via operation of proportional charge pump 90. This may contribute to jitter in output signal 12.

5 Proportional charge pump 90 can cause bias generator 24 to generate noise on biasing signal V_{bn} (i.e., the output of bias generator 24), and thus on the VCO output, even when the system is in lock. Assuming a proportional charge pump of similar construction to the integrating charge pump 40 depicted in Fig. 2, this noise may occur where the current pulse mirrored through transistors 60 and 68 is not sourced at the same
10 time as the current pulse through transistor 62. So although the two pulses are equal, and cancel when integrated, they collectively add a small disturbance to the charge pump output, in this case by introducing a disturbance into biasing signal V_{bn} , which in turn produces a disturbance in the VCO output.

It will be appreciated that the issues just discussed typically are not as applicable
15 to integrating charge pump 40, since the integrating charge pump produces bursts of current that are integrated by and stored at capacitor 42. Thus, in contrast to the transient output of the proportional charge pump, the integrating output is preserved as a small change in control signal V_{cntl} which is applied to multiple subsequent VCO output cycles.

20 The jitter issues discussed above are not confined to PLL systems performing integral frequency multiplication. PLL systems commonly perform rational (i.e., non-integral) frequency multiplication, so as to produce an output frequency which is x/y

times the reference frequency. This is typically achieved by dividing the feedback signal by x and the reference signal by y to achieve overall multiplication by x/y . The feedback divider value may be changed from one compared edge to the next to achieve higher precision or multiplication by an irrational factor. The jitter problems discussed above
5 can affect such PLL systems even more significantly.

One way of addressing these proportional control issues is to place a capacitor on the output of the proportional charge pump. The size of this capacitor is constrained by the loop bandwidth of the PLL system. Specifically, the pole created by the capacitance must be approximately one decade above the loop bandwidth. Consequently, the lower
10 the loop bandwidth, the better a capacitor on the proportional charge pump can filter out jitter.

Instead of, or in addition to the added capacitance discussed above, the PLL systems of the present description may be configured to spread correction signals generated by the charge pump system so that those corrections occur over an increased
15 period of time. For example, phase-locked loop 10 may be provided with a circuit intermediate proportional charge pump 90 and bias generator 24 that is configured to store a charge corresponding to the I_{bp} correcting pulses output by the proportional charge pump. The stored charge is then output over a period of time that is greater than the duration of the original correcting pulse received by the circuit. As will be explained in
20 detail below, this may be achieved by converting the correcting pulse into a series of smaller pulses, into a charge-equivalent current, and/or through other methods.

Fig. 8 depicts a correction circuit 220 configured to convert I_{bp}' pulses 222 produced by proportional charge pump 90 into a series of smaller I_{bp} pulses 224. The I_{bp}' correcting pulse is expressed as the equivalent average charge pump current produced over the reference cycle (T_{ref}). Circuit 220 is coupled in the proportional control path between proportional charge pump 90 and the $V_{replica}$ node of bias generator 24, and typically includes a reset mechanism 226, sampling capacitor 228 (C_{samp}) and output capacitor 230 (C_{out}), and output switch 232.

As discussed above, proportional charge pump 90 periodically produces a correcting pulse I_{bp}' to proportionally control voltage controlled oscillator 30. Typically, these correcting pulses occur in a one-to-one relationship with cycles of the reference signal, as seen in Fig. 7. Each reference cycle, sampling capacitor 228 is reset to V_{cntl} (the stored output level of integrating charge pump 40) via operation of reset mechanism 226, which includes a voltage buffer 234 and a reset switch 236. After the reset operation, sampling capacitor 228 receives I_{bp}' correcting pulse 222 and accumulates a corresponding charge. After capacitor 228 is fully charged, the stored charge is repeatedly dumped over to charge output capacitor 230 via operation of output switch 232, which is controlled by VCO output signal 12. The resulting charge on output capacitor 230 dumps directly into bias generator, resulting in application of a series of I_{bp} pulses 224 to the bias generator $V_{replica}$ node for each one of the original correcting pulses 222. In addition, because output switch 232 is timed with VCO output signal 12, one such partial correcting pulse occurs for each cycle of the output signal. Absent operation of circuit 220, corrections are applied to the loop only once every N cycles of the VCO

output signal, as seen in Fig. 7. Application of the smaller, higher frequency pulses thus reduces jitter in VCO output signal 12.

In many cases it will be advantageous to ensure that the total output charge from circuit 200 equals the total input charge. If $C_{out} = C_{smp}/N$ and there are N VCO cycles
 5 for each reference cycle, then the total charge transferred into the input of circuit 200 will be the same as the total charge that is applied to the $V_{replica}$ node of bias generator 24.

Fig. 9 schematically depicts another circuit implementation configured to spread corrections generated by proportional charge pump 90 over an increased period of time. Similar to circuit 200, circuit 240 is coupled in the proportional control path between
 10 proportional charge pump 90 and bias generator 24. Circuit 240 includes a sampling capacitor 242 configured to integrate correction pulses 222 into a stored charge Q_{ch} . The resulting voltage on capacitor 242 is applied to control a voltage controlled current source 244. Current source 244 typically is controlled by the accumulated charge Q_{ch} such that a charge equivalent to that received from the proportional charge pump is output as a
 15 correcting current 246 over a period of time that is longer than the duration of the received correcting pulse 222. Reset switch 248 resets the sampling capacitor every reference cycle. Fig. 10 depicts an exemplary circuit-level implementation of the system shown in Fig. 9.

In the systems depicted in Figs. 9 and 10,

20
$$Q_{ch} = I_{bp} \cdot T_{ref} \text{ and } V_{smp} = Q_{ch}/C_{smp}; \text{ and}$$

$$I_{bp} = g_m \cdot V_{smp} = g_m \cdot (Q_{ch}/C_{smp}) = \\ g_m \cdot (I_{bp}' \cdot T_{ref})/C_{smp}.$$

For a self-biased PLL, as described above,

$$T_{ref} = N \cdot (C_b/g_m),$$

5 where C_b is the total buffer output capacitance for all stages. Also,

$$I_{bp} = I_{bp}' \cdot N \cdot (C_b/C_{smp}).$$

To get $I_{bp} = I_{bp}'$, we make $C_{smp} = N \cdot C_b$. This factor of N is generally useful, since the proportional charge pump current typically must be a factor of N larger than the integral charge pump current for stability. Using different C_b/C_{smp} ratios, different
10 effective charge pump currents can be obtained without unbalancing the charge pump structure. The derivations of the above equations are presented in an article by John G. Maneatis appearing in the IEEE Journal of Solid State Circuits, vol. 31, no. 11, pp. 1723-1732, Nov. 1996.

It will be appreciated that the invention further encompasses a method of reducing
15 jitter in a phase-locked loop system. Fig. 11 depicts an example of such a method. At 260, the method includes receiving a correcting pulse. As indicated in the preceding discussion, this pulse typically is in the form of a pulsed current provided along the proportion control path feeding the $V_{replica}$ node of bias generator 24. At 262, the method further includes storing a charge based on the pulsed correction signal received in step
20 260. Commonly, this is performed using a sampling capacitor, though other suitable devices and techniques may be used. The stored charge is then output, at 264, over a

period of time greater than the duration of the correcting pulse that was received at step 260. As discussed above, this spreading of the correction signal reduces ripple in the proportional control signal, and thus reduces jitter in the output signal of the phase-locked loop system. The output step may be performed by outputting the stored charge as a series of smaller correcting pulses, or by outputting the stored charge as a relatively constant current applied over a longer duration than that of the original correcting pulse.

Two or more correction circuit stages may be provided in the proportional control path between proportional charge pump 90 and bias generator 24. For example, as seen in Fig. 12, two correction stages 280 and 282 similar to circuit 240 (Figs. 9 and 10) are coupled in the proportional control path to the outputs of proportional charge pumps 284 and 286. This configuration may be advantageous where the duration of the reset operation discussed above lasts for a large portion of a reference cycle. In the depicted example, correction stages 280 and 282 are arranged in parallel, with the sample/reset operations being respectively controlled by reset signals reset1 and reset2, such that the two correction stages integrate on alternating reference cycles. Accordingly, while one correction stage is integrating, the other is being reset.

This implementation can be further extended to three or more correction stages. Where three correction stages are used, each correction stage may be configured to first reset, then wait for a correcting pulse, and then integrate to accumulate a charge. Performance of these functions is staggered among the three stages, such that at any given time, one stage is resetting, a second is waiting, and the third is outputting its accumulated charge.

In addition, as seen in Fig. 12, the reset switch may be configured to selectively connect capacitor C_{samp} to a V_{cntl} replica voltage, V_{cntl}' , instead of being coupled between the gate and drain of transistor 250 (Fig. 10). The circuit depicted in Fig. 12 has two g_m stages (288 and 290) biased by V_{bn} that may be matched to the impedances in voltage controlled oscillator 30 and bias generator 24. Stages 288 and 290 alternately drive a time-averaged proportional control current into the V_{replica} node of bias generator 24.

In the two-stage system shown in Fig. 12, as one sampling capacitor is charged by the charge pump, the other sampling capacitor is reset to V_{cntl} (or the V_{cntl}' replica of V_{cntl}) through a switch. It is normally preferable that the these two waveforms perfectly sum to the prior voltage level so that the I_{bp} current is not disturbed between reference cycles with constant size I_{bp} pulses. However, if the charge pump connected to the resetting sampling capacitor is turned off during reset, then the reset waveform will be an exponential decay as the sampling capacitor discharges. This exponential discharge is different in shape from the charge curve of the active charge pump, as indicated by the V_{samp1} and V_{samp2} voltage plots 320 and 322 shown in Fig. 13.

For many applications, it will be desirable to address this asymmetry by reversing operation of the charge pump connected to the resetting capacitor, instead of turning the charge pump off. As seen in V_{samp1} and V_{samp2} voltage plots 324 and 326, this results in the resetting waveform more nearly matching the sampling waveform so that the waveforms sum to the prior voltage level. As a result, the current injected into V_{replica} by the charge pump system will be more nearly constant.

The charge pump system may be configured in a variety of different ways to cause individual charge pumps to either shut off or pump in reverse. In the depicted exemplary embodiment, this is accomplished via operation of logic networks 300 and 302 (Fig. 12) that receive and process the U and D signals digitally before they enter the charge pump.

5 Specifically, logic networks 300 and 302 are configured to conditionally reverse U and D.

Shorting the sampling capacitors to a V_{cntl} replica V_{cntl}' , rather than to V_{cntl} itself avoids disturbing V_{cntl} with bursts of charge. However, these bursts of charge within the proportional control path may be manipulated to provide the same integrating control that
10 is achieved in the previously described embodiments through the pumping of charge from integrating charge pump 40 into capacitor 42 (Figs. 2 and 3).

Fig. 14 depicts an alternate charge pump system 340, which includes two proportional charge pumps configured to perform both proportional and integral control without use of a separate integrating charge pump. A separate integrating charge pump is
15 optional because sampling capacitors C_{samp1} and C_{samp2} are reset directly to V_{cntl} . Because of this direct coupling to V_{cntl} , each proportional charge pump outputs packets of charge which first perform a proportional control function and then an integral control function. The proportional control function occurs prior to reset when the packet of charge has been stored on one of the sampling capacitors. At this point, the packet of charge
20 contributes to the injection of current into the V_{replica} node of bias generator 24, and thus provides proportional control. Upon reset, the residual charge is dumped directly into V_{cntl} and stored on capacitor 42 (Fig. 3) to provide integrating control.

Figs. 12A-12D depict further embodiments of a correcting circuit/mechanism according to the present description. Referring first to Fig. 12A, the figure provides an equivalent circuit representation of the circuit shown in Fig. 12. Referring now to Fig. 12B, the bias generator feedback loop may be reconfigured so that the negative terminal of the differential amplifier is fed with an averaged value of V_{fs1} and V_{fs2} . Fig. 12C presents an alternate, flipped-over version of the circuit of Fig. 12B. Fig. 12D is an expanded depiction of the circuit, showing a transistor-level representation of the differential amplifier. It will be appreciated that the depicted example provides two alternately activated charge transfer paths via which the charge pumps can dump charge onto sampling capacitors. During each cycle, one of the two charge pumps dumps its charge (e.g., V_{fs1} or V_{fs2}) onto the sampling capacitor while the other may be shorted with the capacitor of the V_{cntl} node to contribute to integral control. Using a transconductance stage (g_m), the two voltages are summed together and driven as a current into a matching $1/g_m$ resistance inside the bias generator as the proportional signal where they are summed with V_{cntl} . Two charge pumps and capacitors may be used to allow a whole comparison cycle for charge equalization. Higher order filtering may be obtained by using $x+1$ capacitors where each is active for x cycles with a gain of $1/x$. Also, if no extra feed-forward gain control is needed, the architecture can be further simplified by summing V_{fs1} and V_{fs2} without V_{cntl} directly at the amplifier input since they are offset by V_{cntl} .

The depicted examples of Figs. 12B-12D enable omission of two current sources. In some settings, this may simplify matching considerations, in that less devices must be matched and the remaining devices may be made larger so that they are easier to match.

Referring again to Fig. 14, eliminating the need for a separate integrating charge pump may provide a number of advantages. Without an integrating charge pump, non-zero proportional pulses resulting from offsets between proportional and integrating charge pumps are eliminated. Such offsets could arise due to device mismatches or if the charge pumps are operating with different currents. Fewer charge pumps also leads to a reduction in supporting circuitry within the PLL system. In addition, any instability associated with the proportional charge pump current being dumped into a V_{cntl} replica is eliminated.

In typical implementations of the charge pump system described, there is no independent control of the currents used to provide integrating and proportional control. However, the capacitors shown in Fig. 14 can be scaled to change the proportional control current independently of the integrating charge pump current. Alternatively, another integrating charge pump, operating at a different current level, could be added to either increase or cancel some of the current into V_{cntl} from sampling capacitors C_{samp1} and C_{samp2} .

In some cases, it is advantageous to use a single charge pump. In this case, the output from a single charge pump can be switched to various sampling capacitors to perform the proportional and integral control functions described above, as shown in Fig. 15.

In some phase-locked loop applications, it is useful to scale down the currents emitted from charge pump system 22. This reduces the rate at which the loop can track changes in the reference signal, which may be desired if the PLL is used to filter noise from the reference signal. Charge pump currents may be reduced in a variety of ways, as will be apparent from the examples below. Also, where both integrating and proportional charge pumps are used, it may be desirable to reduce the respective currents by differing amounts, and/or through different current-reducing techniques and structures.

Various current mirror configurations may be employed to reduce charge pump currents and thereby adjust the bandwidth response of the PLL system. For example, the current mirror defined between the current sources of bias generator 24 and charge pump 40 can be configured to create a ratioed mirror. Specifically, charge pump current source transistors 50 and 52 (Fig. 2) may be configured with a width that is some fraction of the width of transistor 86 within bias generator 24 (Fig. 3). The ratio of bias current I_b within the bias generator and the charge pump current I_{ch} is then specified by:

$$I_b/I_{ch} = W_{86}/W_{50},$$

Where W_{86} is the width of transistor 86 and W_{50} is the width of transistor 50. Transistors 50 and 52 typically are the same width in order to balance the charge pump, i.e. $W_{50} = W_{52}$.

Additional current mirrors may be employed to achieve relatively large current reductions without requiring a large range of transistor sizes. For example, as described above with reference to Fig. 5, a current mirror system may be employed to isolate the

bias input path of the charge pump system. In addition to, or instead of this bias isolation feature, the mirroring system shown in Fig. 5 may be configured to further scale down the charge pump current. In particular, the current mirror system of Fig. 5 may be configured to include two ratioed mirrors. These two current mirrors, together with the
5 size ratio between transistors 86 and 50, result in a the following ratio between bias current I_b and charge pump current I_{ch} :

$$I_b/I_{ch} = (W_{86}/W_{112})(W_{102}/W_{106})(W_{108}/W_{50}).$$

In many cases, it will be preferable to use plural current mirrors cascaded in this manner to achieve larger current reductions.

10 The current mirroring functions described above may be implemented with a programmable current mirror. An illustrative example of such a programmable current mirror is depicted at 400 in Fig. 16.

As indicated, programmable current mirror 400 includes a reference side 402 and a mirror side 404. Mirror side 404 outputs an output current I_O based on a reference
15 current I_R applied to reference side 402. Current mirror 400 is configured to programmably vary a mirroring parameter M which defines the ratio relationship between the reference current and the output current. In particular, the relationship between the reference current, output current and mirroring parameter is defined by the equation $I_O = M \cdot I_R$. As will be appreciated from the following description, mirroring
20 parameter M may be an integer or a rational number.

Either or both sides of programmable current mirror 400 may include one or more switchable current conducting legs couple in parallel, with each leg having a transistor

406 that is selectively activated via operation of a switch 408. Activating and deactivating the various transistor legs on the reference side varies the effective width-to-length ratio of the reference transistors, which in turn leads to variation of the voltage at node 410. This node voltage controls the biasing conditions which determine the current
5 produced on output side 404 of programmable current mirror 400. As indicated, the output side may similarly include multiple switchable legs, to provide control over the effective width-to-length ratio of the output transistors. In the depicted arrangement, the mirroring parameter M is specified by $M = W_O/W_R$, such that $I_O = W_O/W_R \cdot I_R$, where W_O is the effective width-to-length ratio of the activated output transistors, and W_R is the
10 effective width-to-length ratio of the activated reference transistors.

Switching typically is achieved via application of a control word to control the state of the various switches, using digital encoding, thermometer encoding, or other appropriate techniques. The individual transistors may be of the same size, may have sizes that are binary-scaled, or may have other relative dimensions as appropriate to a
15 given setting.

In addition, either or both sides of programmable current mirror 400 may include gain blocks to provide the programmable current mirror with a multistage configuration. For example, Fig. 17 schematically depicts gain blocks 420 coupled with current blocks 422 on the reference side of a programmable current mirror. Each current block 422
20 includes one or more current conducting legs as described above with reference to Fig. 16. Typically, each current block 422 will include a number of switchable current legs. Gain blocks 420 are interposed between the current blocks, and typically include a fixed

current mirror. For a given current block 422 (e.g., a transistor or group of transistors that are selectively activated as described above), the connected gain block 420 is configured to reduce gate voltages for the current block, in order to scale down the effect upon the mirroring parameter produced by switching operations occurring at the current block. Figs. 18 and 19 depict exemplary embodiments of fixed current mirrors that may be implemented to provide gain between the current block stages. Specifically, Fig. 18 depicts a fixed current mirror that may be used to provide a gain reducing feature between current blocks on the reference side of programmable current mirror 400, while Fig. 19 depicts a fixed current mirror that may be used to reduce gain between stages on the output (mirror) side of the programmable current mirror.

From the above, it should be appreciated that programmable current mirror may be implemented with programmable capability on the reference side, the output side, or both. Further, either or both sides may be implemented with a multistage configuration, though use of gain blocks 420. When the reference side only is provided with programmable capability, the resulting configuration may be referred to as an inverse programmable current mirror, due to the fact that switching operations affect the denominator of mirroring parameter M . Where the output side only is programmable, the configuration is referred to simply as a programmable current mirror, because switching operations affect the numerator of the mirroring parameter M . Where both sides include programmable capability, the current mirror may be considered a rational programmable current mirror. The transistor legs and switching controls may also be implemented so that incrementing the control word produces linear variation in the numerator and/or

denominator of the mirroring parameter. Linear variation in the denominator is referred to as inverse-linear programmability.

Typically, as described above, the programmable current mirror may be employed in connection with the circuits used to isolate the bias input path of the charge pump system. For example, a programmable current mirror as described above may be used to
5 create a ratioed mirror between transistor 112 (Fig. 5) and transistor 50 (Fig. 2).

Additionally, or alternatively, a programmable current mirror may be employed within the proportional control path defined between the charge pump system and the V_{replica} node of bias generator 24. Where a programmable current mirror such as that
10 described above is interposed in the proportional control path, the current mirror provides high-resolution control over the scale factor between the current output from the proportional charge pump and the current that is ultimately injected into the bias generator at the V_{replica} node. Use of a programmable current mirror has the advantage of making the PLL loop bandwidth programmable during operation, rather than being a
15 parameter fixed at design time.

Further examples of programmable current mirrors that may be used with the present description are disclosed in U.S. Patent No. 6,462,527, issued October 8, 2002, which is hereby incorporated by reference.

Instead of, or in combination with, the above techniques and structures for
20 reducing charge pump currents, the PLL systems of the present description may be configured to reduce the number of charge pulses produced by charge pump system 22. These configurations may be employed to reduce output pulses in both the proportional

and integrating control paths of the charge pump output, though the method has proved particularly advantageous when applied to integrating charge pump 40.

Fig. 20 depicts a gating mechanism 460 coupled with phase frequency detector 16 and integrating charge pump 40. As indicated, gating mechanism includes an N-counter 462 connected to the reference line, and gates 464 and 466 coupled in the U and D signal paths between phase frequency detector 16 and integrating charge pump 40. Counter 462 includes a carry output that pulses true once for every N reference cycles, such that the frequency of the error signals (e.g., U and D signals 18 and 20) applied to the integrating charge pump inputs is reduced by a factor of N. This effectively reduces the integrating charge pump current to $1/N$ of what it would be absent operation of gating mechanism 460.

The reference input to counter 462 can be simply connected to the complement of the reference signal as shown. In some applications, the duty cycle of the reference signal may be relatively uncontrolled, such that the falling edges of the reference signal overlap with the U and D pulses. This may be remedied through use of other clock signals. For example, the counter's clock may be generated from the NAND of the U and D signals or directly from the reset signal contained inside the phase frequency detector that is used to reset the U and D outputs.

The loop bandwidth and multiplication factor N can be adjusted in a PLL design while keeping the loop dynamics constant by appropriately adjusting the charge pump currents. In order to keep the bandwidth to reference frequency ratio and the damping factor constant with changes in N, the integrating charge pump current must be reduced

by the factor N and the proportional charge pump current must be held constant. Alternatively, with a fixed N , the damping factor can be held constant while the loop bandwidth is reduced by a factor R if the integrating charge pump current is reduced by the factor R^2 and the proportional charge pump current is reduced by the factor R .

5 While the present description has been particularly shown and described with reference to the foregoing preferred embodiments, those skilled in the art will understand that many variations may be made therein without departing from the spirit and scope of the invention as defined in the following claims. In particular, the circuits and methods discussed above may be implemented in connection with any family of charge pump, bias
10 generator and VCO circuits. The description of the invention should be understood to include all novel and non-obvious combinations of elements described herein, and claims may be presented in this or a later application to any novel and non-obvious combination of these elements. Where the claims recite “a” or “a first” element or the equivalent thereof, such claims should be understood to include incorporation of one or more such
15 elements, neither requiring nor excluding two or more such elements.